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CONFIRMATION NO. 3542

SERIAL NUMBER 10/561,957	FILING OR 371(c) DATE 12/22/2005 RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 126273	
APPLICANTS Tsuyoshi Nishizawa, Fukushima, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/08725 06/21/2004 <i>Smm</i> ** FOREIGN APPLICATIONS ***** JAPAN 2003-182615 06/26/2003					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/06/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance <i>S.M. Nishizawa</i> <i>Smm</i> Verified and Acknowledged Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 3
ADDRESS 25944					
TITLE Method for producing silicon epitaxial wafer and silicon epitaxial wafer					
FILING FEE RECEIVED 950	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		